

INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 16, 2025

IGI Report Number  
Description  
Shape and Cutting Style  
Measurements

LG735511117  
LABORATORY GROWN DIAMOND  
PEAR BRILLIANT  
9.84 X 6.32 X 4.07 MM

GRADING RESULTS

Carat Weight  
Color Grade  
Clarity Grade

1.46 CARAT  
D  
VS 1


ADDITIONAL GRADING INFORMATION

Polish  
Symmetry  
Fluorescence

EXCELLENT  
EXCELLENT  
NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG735511117

Report verification at igi.org

PROPORTIONS

Medium To Slightly Thick (Faceted)

61%

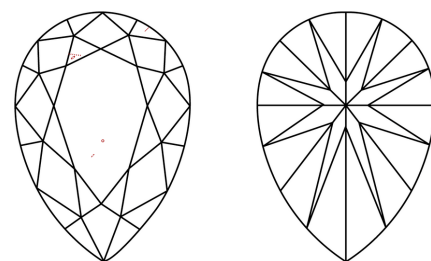
13%

47.5%

64.4%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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IGI



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